

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT--

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Barry Lee-Mean Yang et al.

Filing Date

March 17, 1999

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## U.S. PATENT DOCUMENTS

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✓ <i>HP</i>	AA 3 6 2 5 8 4 8	12/07/71	Snaper	204	192	
✓ <i>HP</i>	AB 5 5 7 1 3 3 2	11/05/96	Halpern	118	723 HC	
	AC					
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	AH					
	AI					
	AJ					
	AK					

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	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES No
✓ <i>HP</i>	AL 3 0 1 4 2 5 8	10/15/81	Germany			
✓ <i>HP</i>	AM 0 8 8 7 4 3 7	12/30/98	EPO			English
	AN					
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	AP					

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✓ <i>HP</i>	AR	Database WPI, Derwent Publications Class A09, AN 1993-411476 XP-002138601, "Light Source Apparatus for Weather Resistant Testing of Organic Material", JP 05312715 A, (1993). <i>abstract</i>
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EXAMINER		DATE CONSIDERED
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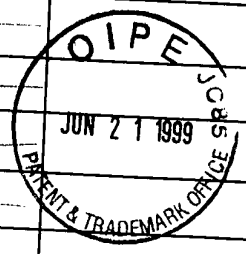
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*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
✓ MJP	AA 3 1 6 1 6 1 5	12/15/64	Goldberg			
✓	AB 3 2 2 0 9 7 3	11/30/65	Goldberg			
✓	AC 3 3 1 2 6 5 9	04/04/67	Kurkky et al.			
✓	AD 3 3 1 2 6 6 0	04/04/67	Kurkky et al.			
✓	AE 3 3 1 3 7 7 7	04/11/67	Elam et al.			
✓	AF 3 5 7 6 6 5 6	04/27/71	Webb et al.			
✓	AG 3 6 6 6 6 1 4	06/24/69	Snedeker et al.			
✓	AH 3 9 8 9 6 7 2	11/02/76	Vestergaard			
✓	AI 4 1 9 4 0 3 8	03/18/80	Baker et al.			
✓	AJ 4 2 0 0 6 8 1	04/29/80	Hall et al.			
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✓ MJP	AL 9 2 1 3 5 1 7	02/04/92	PCT Mitchell et al.			
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✓ <i>MLP</i>	BA 4 2 2 4 3 7 8	09/23/80	Schroeter et al.			
✓	BB 4 2 4 2 3 8 1	12/30/80	Goossens et al.			
✓	BC 4 4 5 4 2 7 5	06/12/84	Rosenquist			
✓	BD 4 8 4 2 9 4 1	06/27/89	Devins et al.			
✓	BE 4 8 7 1 5 8 0	10/03/89	Schram et al.			
✓	BF 4 9 2 7 7 0 4	05/22/90	Reed et al.			
✓	BG 4 9 4 8 4 8 5	08/14/90	Wallsten et al.			
✓	BH 5 0 0 8 1 4 8	04/16/91	Thurm et al.			
✓	BI 5 0 5 1 3 0 8	09/24/91	Reed et al.			
✓	BJ 5 1 5 6 8 8 2	10/20/92	Rzad et al.			
✓ <i>MLP</i>	BK 5 2 9 8 5 8 7	03/29/94	Hu et al.			

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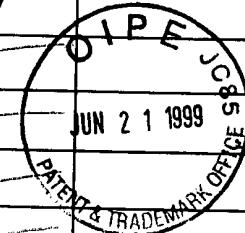
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✓ <i>HRP</i>	CA 5 3 2 0 8 7 5	06/14/94	Hu et al.			
	CB 5 4 3 3 7 8 6	07/18/95	Hu et al.			
	CC 5 4 6 3 0 1 3	10/31/95	Tokuda et al.			
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